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CONFIRMATION NO. 6657

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APPLICANTS Takaaki Noda, Toyama, JAPAN; Kenichi Suzaki, Toyama, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/05699 03/28/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-094488 03/29/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/26/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /KELLY M Acknowledged STOUFFER/ Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 6	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 3
ADDRESS OLIFF & BERRIDGE, PLC P.O. BOX 320850 ALEXANDRIA, VA 22320-4850 UNITED STATES						
TITLE Method of manufacturing semiconductor device and apparatus for processing substrate						
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			